OIPE
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PATENT & TRADEMARK OFFICE

Attorney Docket No. 0756-7209

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	Group Art Unit: 2894
Shunpei YAMAZAKI et al.	)	Examiner: Brook Kebede
Serial No. 10/678,083	)	
Filed: October 6, 2003	)	
For: METHOD OF IRRADIATING LASER, LASER IRRADIATION SYSTEM, AND MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE	)	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 2, 2009.

Adam M Stamper

RESPONSE

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Official Action mailed October 2, 2008, has been received and its contents carefully noted. This response is filed within three months of the mailing date of the Official Action and therefore is believed to be timely without extension of time. Accordingly, the Applicant respectfully submits that this response is being timely filed.

The Applicant notes with appreciation the consideration of the Information Disclosure Statements filed on October 6, 2003; December 19, 2003; February 17, 2005; March 1, 2005; July 5, 2005; January 5, 2006; March 21, 2006; June 13, 2006; August 29, 2006; December 28, 2006; June 22, 2007; July 5, 2007; and October 16, 2007.

However, the Applicant has not received acknowledgment of the Information Disclosure Statement filed on August 27, 2008 (received by OIPE August 29, 2008).

Also, an Information Disclosure Statement is submitted herewith and consideration of this Information Disclosure Statement is respectfully requested.